

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**priority** Application Serial No. .... 10/364,054  
**priority** Filing Date ..... February 10, 2003  
Inventor..... Luan C. Tran  
Assignee..... Micron Technology, Inc.  
**priority** Group Art Unit ..... 2812  
**priority** Examiner ..... Kennedy, Jennifer J.  
Attorney's Docket No. .... MI22-2358  
Title: Methods of Forming Semiconductor Constructions

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**